

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:

T. UCHIDA, et al.

Application No.: 09/763,891

Filed:

June 11, 2001

For:

POLISHING SOLUTION FOR METAL AND POLISHING METHOD

Art Group:

1765

Examiner:

L. Umez Eronini

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR §1.97 & §1.98

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 June 24, 2004

Sir:

Pursuant to Applicants' duty of disclosure, enclosed please find a copy of an Office Action, and copies of documents cited therein, in connection with a Korean patent application corresponding to the above-identified application. Also enclosed is an English abstract of Japanese Patent Document No. 08-083780, the Japanese patent document being cited in the enclosed Office Action, and a copy of International (PCT) Publication No. WO 00/00561, corresponding to the same U.S. patent application that Korean Patent Document No. 2001-53167 corresponds to, No. 2001-53167 being cited in the enclosed Korean Office Action.

Further enclosed is a Form, substantially equivalent to Form PTO-1449, listing the documents cited in the enclosed Office Action.

This Information Disclosure Statement is being submitted subsequent to a non-final Office Action on the merits in the above-identified application. For

satisfying requirements of 37 C.F.R. §1.97(c), the following Statement is made under 37 C.F.R. §1.97(e):

Each item of information contained in this Information Disclosure Statement and listed on the enclosed Form substantially equivalent to Form PTO-1449 was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the Information Disclosure Statement.

To the extent that the enclosed documents, listed on the enclosed Form are not in English, it is respectfully submitted that requirements of 37 C.F.R. §1.98(a)(3) as satisfied by the enclosed English abstract of No. 8-83780, and by the corresponding English language document to No. 2001-53167.

In view of all of the foregoing, it is respectfully submitted that all applicable requirements of 37 C.F.R. §1.97 and 1.98 have been satisfied, in connection with each of the documents listed on the enclosed Form. Accordingly, consideration of the listed documents, upon further examination of the above-identified application, is respectfully requested.

Please charge any shortage in fees due in connection with the filing of this paper to the Deposit Account No. 01-2135 (Case No. 566.39787X00) and please credit any excess fees to such Deposit Account.

Respectfully submitted,

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Form PTO-1449 **U.S. DEPARTMENT OF COMMERCE** ATTY. DKT. **APPPLICATION** PATENT AND TRADEMARK OFFICE NO. NO. 09/763,891 566.39787X00 **APPLICANT** INFORMATION DISCLOSURE STATEMENT T. UCHIDA, et al. BY APPLICANT **FILING DATE GROUP** (Use several sheets if necessary) June 11, 2001 1765 **U.S. PATENT DOCUMENTS**

Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date
	AA	<u> </u>					
	AB			· ·			
	AC						
	AD						

FOREIGN PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Country	Class	Subclass	Translation/ Abstracts	
							Yes	No
	AE	08-083780	03/26/96	Japan			Abstract	
	AF	WO 00/00561	01/06/00	PCT (WIPO)				
	AG	2001-53167	06/25/01	Korea				
	AH							
	Al					•		
	AJ							
	AK							
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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

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Examiner Date Considered

Burden Hour Statement: This form is estimated to take 2.0 hours to complete. Time will vary depending upon the needs of the individual case. Any comments on the amount of time you are required to complete this form should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, Washington, DC

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Applicant's unique citation designation number (optional). ²See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³Enter Office that issued the document, by the two-letter code (WIPO Standard St.3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to place a check mark here if English language Translation is attached.